TRANSMITTAL OF FORMAL DRAWINGS				Docket No. YOR920010308US1 (16315)	
In Re Application Of: Jack O. Chu, et al. FEB 2 5 2004					
Serial No.	Filing Date	Confirmation to	Examin	Examiner	
09/838,892	4/20/2001	1665	S. Mulpu	ri	2812
Invention: EPITAXIAL AND POLYCRYSTALLINE GROWTH OF Si1-x-yGexCy AND Si1-yCy ALLOY LAYERS ON Si BY UHV-CVD					
Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450					
, 	are: s of formal drawing(s) fo		ested in 37 CFR Se	ction 1.84(c)).
Steven Fischman Registration No.	. 34,594 ГТ, MURPHY & PRESS y Plaza	SER	are being depos U.S. Postal Serv	s document a ited on ice as first cla	nd attached formal drawings with the ss mail under 37 C.F.R. 1.8 sioner for Patents, P.O. Box

1450, Alexandria, VA 22313-1450.

Signature of Person Mailing Correspondence

Typed or Printed Name of Person Mailing Correspondence